



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Docket No.: 6192.0091.D2

Woon-Yong PARK, *et. Al.*

Serial No.: 10/627,752

Group Art Unit: 1756

Confirmation No.: 4396

Filed: July 28, 2003

Examiner: TBA

For: **PHOTOLITHOGRAPHY METHOD FOR THIN FILM (AS AMENDED)**

Mail Stop: Missing Parts
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO NOTICE TO FILE CORRECTED APPLICATION PAPERS

Sir:

In response to the Notice to File Corrected Application Papers mailed November 4, 2003, Applicants respectfully files the following Amendments and Remarks.

Applicants believe that no extensions of time are required at this time. If extensions of time are necessary to prevent abandonment of this application, then such extensions of time are hereby petitioned for under 37 C.F.R. §1.136(a). Applicants believe that no further fees for net addition of claims are required at this time. Any fees required for further extensions of time and any fees for the net addition of claims are hereby authorized to be charged to our Deposit Account No. 23-1951.